	Application No.	Applicant(s)	
Notice of Allowability	09/916,530	MIYASHITA ET AL.	
	Examiner	Art Unit	
	Ron E Pompey	2812	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.			
 This communication is responsive to <u>10-8-03</u>. The allowed claim(s) is/are <u>10-11 and 20-21</u>. The drawings filed on are accepted by the Examine 			
4. ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) ☐ All b) ☐ Some* c) ☐ None of the:			
 Certified copies of the priority documents have been received. 			
2. \boxtimes Certified copies of the priority documents have been received in Application No. $\underline{09/164,343}$.			
3. Copies of the certified copies of the priority documents have been received in this national stage application from the			
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
5. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application) since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78.			
(a) The translation of the foreign language provisional application has been received.			
6. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121 since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78.			
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE .			
7. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.			
8. ☐ CORRECTED DRAWINGS (as "replacement sheets") must be submitted. (a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached			
1) 🔲 hereto or 2) 🔲 to Paper No			
(b) including changes required by the proposed drawing correction filed, which has been approved by the Examiner.			
(c) 🔲 including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No			
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the margin according to 37 CFR 1.121(d).			
9. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT FOR T			Note the
Attachment(s)			
1⊠ Notice of References Cited (PTO-892)	5☐ Notice of Info	ormal Patent Application (PTO	-152)
2 Notice of Draftperson's Patent Drawing Review (PTO-948)		nmary (PTO-413), Paper No.	*
3☐ Information Disclosure Statements (PTO-1449 or PTO/SB/08	3), 7□ Examiner's A	mendment/Comment	
Paper No 4 Examiner's Comment Regarding Requirement for Deposit		Statement of Reasons for Allov	vance
of Biological Material	9☐ Other		
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Allowable Subject Matter

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1. Claims 11-12 and 20-21 are allowed.

2. The following is an examiner's statement of reasons for allowance: the prior art of

record, either singly or in combination, fails to disclose the limitation(s) of inhibiting

silicidation of the source-drain diffusion region only and to from a first silicide film on the

source-drain region and a second silicide film on the gate electrode, wherein the second

silicide film having a thickness greater than that of the first silicide film..

Any comments considered necessary by applicant must be submitted no later

than the payment of the issue fee and, to avoid processing delays, should preferably

accompany the issue fee. Such submissions should be clearly labeled "Comments on

Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Ron E Pompey whose telephone number is (571) 272-

1680.

Any inquiry of a general nature or relating to the status of this application or

proceeding should be directed to the receptionist whose telephone number is (703) 308-

0956.

Ron Pompey

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December 12, 2003

John F. Niebling

Supervisory Patent Examiner

Technology Center 2800